

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : U.S. National Stage of PCT/JP2004/012471  
Applicant : N. Saeki  
Filed : Aug. 17, 2006  
Title : Plasma Processing Method and Apparatus thereof  
Docket No. : SAEK3002/FJD  
Customer No. : 23364

INFORMATION DISCLOSURE STATEMENT

COMMISSIONER FOR PATENTS  
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Sir:


Pursuant to 37 C.F.R. §1.51(b), §1.56, §1.97, and §1.98, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. A copy of each document listed on form PTO-1449 is submitted herewith (with the exception of the U.S. references).

This Information Disclosure Statement is submitted within three months of the filing date of the above-identified U.S. Patent application.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Respectfully submitted,

Date: Aug. 17, 2006

  
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<b>B/O Form PTO-1449</b>  U.S. Department of Commerce Patent and Trademark Office  Information Disclosure Statement by Applicant	Atty. Docket Number <b>SAEK3002/FJD</b>	Serial Number <b>Unassigned</b>
	Applicant <b>N. Saeki</b>	
	Filing Date <b>Aug. 17, 2006</b>	Group <b>Unassigned</b>

**U.S. Patent Documents**

Examiner Initial		Document Number	Date	Patentee/Applicant	Class	Subclass	Filing Date if Appropriate

**Foreign Patent Documents**

Examiner Initial		Document Number	Publication Date	Country/Agency	Class	Subclass	Translation	
							Yes	No
		JP 11060759	Mar. 5, 1999	Japan				
		JP 2002305070	Oct. 18, 2002	Japan				
		JP 2003086393	Mar. 20, 2003	Japan				
		JP 11512651T	Nov. 2, 1999	Japan				
		JP 2002332572	Nov. 22, 2002	Japan				
		JP 5059198	Mar. 9, 1993	Japan				
		JP 7226395	Aug. 22, 1995	Japan				
		2002-158219	May 31, 2002	Japan				

**Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)**


Examiner	Date Considered
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